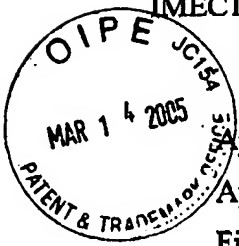


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PATENT

IMEC197.001CP1



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Chetan Singh Solanki
Appl. No. : 10/670,754
Filed : September 24, 2003
For : METHOD AND APPARATUS
FOR CONTINUOUS
FORMATION AND LIFT-OFF OF
POROUS SILICON LAYERS
Examiner : Evan T. Pert
Group Art Unit : 2829

CERTIFICATE OF MAILING

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

(Date)

John M. Carson, Reg. No. 34,303

DECLARATION OF CHETAN SINGH SOLANKI UNDER 37 CFR § 1.132

I, Chetan Singh Solanki, declare and state as follows:

1. I am the sole inventor of the invention claimed in the above captioned patent application and am a co-author the publication of the 3rd World Conference on Photovoltaic Energy Conversion, entitled "THIN MONOCRYSTALLINE SILICON FILMS FOR SOLAR CELLS" which was cited as prior art in the application.

2. The co-authors of the publication, R. R. Bilyalov, G. Beaucarne, and J. Poortmans, were members of my research team and/or supervisors who are therefore listed as co-authors because of such professional relationships.

3. I declare that all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements ~~were made with the knowledge that willful, false statements and the like so made are punishable by~~ fine or imprisonment, or both, under Section 1001 Title 18 of the United States Code and that such willful, false statements may jeopardize the validity of the application or document or any patent resulting therefrom.

Dated: 15/02/2005

By: 
Chetan Singh Solanki

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